

Electronic Acknowledgement Receipt

EFS ID:	3896485
Application Number:	10516455
International Application Number:	
Confirmation Number:	2876
Title of Invention:	Method and device for substrate etching with very high power inductively coupled plasma
First Named Inventor/Applicant Name:	Michel Puech
Customer Number:	23373
Filer:	Michael R. Dzwonczyk/Lynette Mansfield
Filer Authorized By:	Michael R. Dzwonczyk
Attorney Docket Number:	Q84452
Receipt Date:	05-SEP-2008
Filing Date:	03-DEC-2004
Time Stamp:	15:51:52
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$930
RAM confirmation Number	1249
Deposit Account	194880
Authorized User	

The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:

Charge any Additional Fees required under 37 C.F.R. 1.492 (National application filing, search, and examination fees)

Charge any Additional Fees required under 37 C.F.R. Section 1.17 (Patent application and reexamination processing fees)

Charge any Additional Fees required under 37 C.F.R. Section 1.19 (Document supply fees)

Charge any Additional Fees required under 37 C.F.R. Section 1.21 (Miscellaneous fees and charges)

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1		Q84452RCE.PDF	124831 946089cd68c022be90a3bb330da81b27390e3d8	yes	7

	Multipart Description/PDF files in .zip description				
	Document Description		Start	End	
	Request for Continued Examination (RCE)		1	1	
	Amendment Submitted/Entered with Filing of CPA/RCE		2	2	
	Claims		3	4	
	Applicant Arguments/Remarks Made in an Amendment		5	6	
	Extension of Time		7	7	

Warnings:

Information:

2	Fee Worksheet (PTO-06)	fee-info.pdf	31927 7e0f020179f2a7f2edcf943dab1a58ca6f6dd a3c	no	2
---	------------------------	--------------	---	----	---

Warnings:

Information:

Total Files Size (in bytes):			156758
------------------------------	--	--	--------

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.